AMENDMENTS TO THE CLAIMS

This listing of claims will replace all prior versions, and listings, of claims in the application.

Listing of Claims:

1. (Currently Amended) An IPS mode LCD device comprising:

first and second substrates opposite each other, each substrate having an active region and a dummy region;

gate and data lines substantially perpendicular to each other;

a pixel electrode and a common electrode in the active region of the first substrate;

a black matrix layer in the dummy region of the second substrate;

a UV-hardening sealant at a circumference of the black matrix layer between the first and second substrates, wherein the UV-hardening sealant bonds the first and second substrates together;

a metal pattern between the UV-hardening sealant and the first substrate; and,

a liquid crystal layer between the first and second substrates bonded by the UV-hardening sealant,

wherein the metal pattern completely overlaps the UV-hardening sealant <u>and is formed at</u> four edges of the first substrate.

2. (Currently Amended) The IPS mode LCD device of claim 1, wherein the metal pattern is [on] of the same material as the gate line.

3. (Original) The IPS mode LCD device of claim 1, wherein the UV-hardening sealant includes one of epoxy acrylate resin, urethane acrylate resin and polyester acrylate.

- 4. (Original) The IPS mode LCD of claim 1, further including column spacers for maintaining a cell gap between the first and second substrates, and an overcoat layer.
 - 5. (Withdrawn) An IPS mode LCD device comprising: first and second substrates opposite to each other, each substrate having an active region and a dummy region;
 - a black matrix layer in the dummy region of the second substrate;
- a UV-hardening sealant at a circumference of the black matrix layer between the first and second substrates, wherein the UV-hardening sealant is used for bonding the first and second substrates to each other;
- a liquid crystal layer between the first and second substrates bonded by the UV-hardening sealant.
- 6. (Withdrawn) The IPS mode LCD device of claim 5, wherein the first substrate has an IPS mode thin film transistor array including gate and data lines substantially perpendicular to each other, a pixel electrode and a common electrode in the active region thereof.
- 7. (Withdrawn) The IPS mode LCD device of claim 5, wherein the UV-hardening sealant includes one of epoxy acrylate resin, urethane acrylate resin and polyester acrylate.

8. (Withdrawn) The IPS mode LCD devide of claim 5, further including column spacers for maintaining a cell gap between the first and second substrates, and an overcoat layer.

9. (Currently Amended) A method for manufacturing an IPS mode LCD device comprising:

forming gate lines crossing data lines on a first substrate;

forming a pixel electrode and a common electrode on the first substrate;

forming a metal pattern in a dummy region of the first substrate having active and dummy regions;

forming a black matrix layer in a dummy region of a second substrate having active and dummy regions;

depositing a UV-hardening sealant at a circumference of the black matrix layer on the second substrate;

bonding the first and second substrates to each other after placing the UV-hardening sealant to the first substrate; and

irradiating a UV ray to harden the UV-hardening sealant;

wherein the metal pattern completely overlaps the UV-hardening sealant <u>and is formed</u> at four edges of the first substrate.

- 10. (Original) The method of claim 9, wherein the UV-hardening sealant includes one of epoxy acrylate resin, urethane acrylate resin and polyester acrylate.
- 11. (Original) The method of claim 9, wherein the metal pattern is formed of the same material as a gate line.

12. (Original) The method of claim 9, further comprising dispensing liquid crystal on the active region of the first substrate before bonding the first and second substrates together.

- 13. (Original) The method of claim 9, wherein the UV-hardening sealant is completely hardened with the UV ray reflected from the metal pattern.
- 14. (Withdrawn) A method for manufacturing an IPS mode LCD device comprising: forming a black matrix layer in a dummy region of a second substrate having active and dummy regions;

depositing a UV-hardening sealant at a circumference of the black matrix layer on the second substrate;

bonding the first and second substrates to each other after facing the UV-hardening sealant to the first substrate; and

irradiating a UV ray to harden the UV-hardening sealant.

- 15. (Withdrawn) The method of claim 14, further comprising dispensing a liquid crystal on the active region of the first substrate before bonding the first and second substrate together.
- 16. (Withdrawn) The method of claim 14, wherein the UV-hardening sealant includes one of epoxy acrylate resin, urethane acrylate resin and polyester acrylate.